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Date: February 20, 2002 Must Be Sent
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION OF
Inventors: Heikyung Min et al.

Appn. No.: 10 | 032,930
Series Code ↑ | Serial No. ↑

Filed: October 29, 2001

Title: APPARATUS AND METHOD FOR REDUCING SURFACE ZENER DRIFT USING Ti-BASED METALLURGY

Date: February 20, 2002

Commissioner for Patents
Washington, D.C. 20231
Attn.: Office of Initial Patent Examination

Sir:

REQUEST FOR CORRECTED FILING RECEIPT

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2. There is an error with respect to the following data which is

incorrectly entered and/or
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omitted
Correct data

1. Third Applicant's First Name
2. Robert Spence

Please see the attached copy of Declaration as filed.

3. It is understood that the PTO no longer charges for correcting filing receipts even when the error is applicants' mistake, but if that is incorrect and a fee is due for this correction please charge our Deposit Account No. 03-3975 under Order No. 072219-0278269

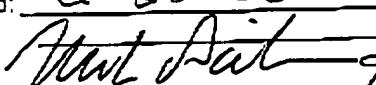
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By Atty: Mark C. Pickering

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Dated: 2-20-02

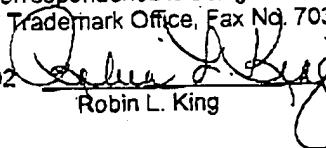
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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
10/032,930	10/29/2001	2811	740	072219-0278259 (P05108)	7	20	2

CONFIRMATION NO. 8013

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Applicant(s)

Heikyung Min, Palo Alto, CA;
Steven Kurihara, San Jose, CA;
Spence, Skelmorlie, UNITED KINGDOM;
ROBERT

Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted 02/06/2002

Projected Publication Date: Request for Non-Publication Acknowledged

Non-Publication Request: Yes

Early Publication Request: No

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Title

Apparatus and method for reducing surface zener drift using Ti-based metallurgy

Preliminary Class

257

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